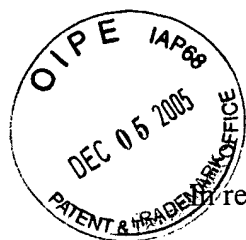


IFW

03599.000083.

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of:

TOMIO NAKAYAMA, et al.

Application No.: 10/725,403

Filed: December 3, 2003

For: PLASMA PROCESSING
APPARATUS AND METHOD

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Examiner: L. Alejandro Mulero
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Group Art Unit: 1763
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December 2, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents, together with English-language abstracts, are enclosed.

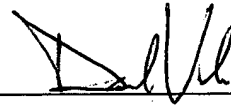
The listed documents were cited in an Official Action in a corresponding Korean application. A copy of the Korean Official Action, which is dated August 31, 2005, is enclosed. An English-language translation of the Official Action is also enclosed.

This Information Disclosure Statement is being filed before the issuance of a first Office Action on the merits. Therefore, no fee under 37 C.F.R. § 1.97(c)(2) is believed due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Costa Mesa, California office at (714) 540-8700. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,



Damond E. Vadnais
Attorney for Applicants
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